



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application Of:) Confirmation no. 7871
)
Won Hwa JIN) Group Art Unit: 2823
)
Application Number: 10/608,082) Examiner: W. Brewster
)
Filed: July 30, 2003)
)
For: METHOD FOR FORMING METAL LINE OF SEMICONDUCTOR DEVICE

CHANGE OF CORRESPONDENCE ADDRESS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

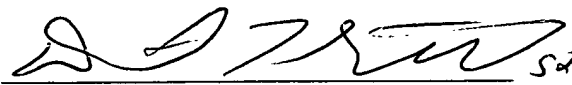
Sir:

Please address all future correspondence in the above-identified application to:

Johnny A. Kumar, Esquire
Heller Ehrman White & McAuliffe LLP
1717 Rhode Island Avenue, N.W.
Washington, D.C. 20036
Tel. No. (202) 912-2000
Fax No. (202) 912-2020

Respectfully submitted,

Date: 3/11/05


s2987
for/ Johnny A. Kumar
Reg. No. 34,649

Heller Ehrman White & McAuliffe
1717 Rhode Island Avenue, N.W.
Washington, D.C. 20036
Telephone: (202) 912-2000
Facsimile: (202) 912-2020

Attorney for Applicants
Customer I.D. No. 26633